

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10613513	
	Filing Date		2003-07-03	
	First Named Inventor	Brian Y. Lim		
	Art Unit	1725		
	Examiner Name	Maria Alexandra Elve		
Attorney Docket Number		ATOMP001		

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1	R. ALEXANDRESCU et al., "The Catalyzed Growth of Carbon Nanotubes in the Laser - Assisted Chemical Vapor Deposition Processes," Nanoscale Physics Research Laboratory, IUVSTA Workshop on Nanoparticles, 2001, p. 1	<input type="checkbox"/>
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☐ That each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. See 37 CFR 1.97(e)(1).

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- ☐ See attached certification statement.
- ☒ Fee set forth in 37 CFR 1.17 (p) has been submitted herewith.
- ☐ None

SIGNATURE

A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

Signature	/Melvin D. Chan/	Date (YYYY-MM-DD)	2006-09-07
Name/Print	Melvin D. Chan	Registration Number	39626

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